

The

In re the Application of: Katsuto TANAHASHI et al.

Group Art Unit: 3663

Application Number: 10/743,793

Examiner: Johannes P. Mondt

Filed: December 24, 2003

Confirmation Number: 9788

For:

SEMICONDUCTOR SUBSTRATE AND MANUFACTURING

METHOD THEREOF

Attorney Docket Number:

032206

Customer Number:

38834

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 May 3, 2006

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated January 4, 2006 for one month from April 4, 2006 to May 4, 2006.

Attached please find a check in the amount of \$120.00 for the cost of the extension.

If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

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